



## Professor Jeon G. Han

Professor in Advanced Materials Engineering, Sungkyunkwan University

Director of Center for Advanced Plasma Surface Technology

Republic of Korea

- Expertise : Advanced Plasma Technology and Advanced Functional Coating Material & Process
- Patents:
  - EP1120811: Planar-type magnetron sputtering apparatus
  - 25 Patent Registrations
  - 16 Patent Applications



CAPST



# Special Seminar

**CAPST: Advanced Research Institute in Industrial Environment & Advanced Plasma Technology for Nano-science, Materials-science and Bio-medicine**

Place: B201

Time : 13:45 – 15:00

Date: January 31, 2012

*Co-Sponsored by Graduate Programme in Physics & Graduate programme in Materials Science and Engineering*